

Title (en)
SURFACE TREATMENT METHOD AND TREATMENT APPARATUS

Title (de)
OBERFLÄCHENBEHANDLUNGSVERFAHREN UND -VORRICHTUNG

Title (fr)
PROCEDE ET APPAREIL DE TRAITEMENT DE SURFACE

Publication
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Application
EP 00906046 A 20000207

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Abstract (en)
[origin: WO0047794A1] A method for treating a substrate in a fluidised bed treatment facility using a halide gas plus a nitrogen and/or carbon containing gas introduced from a source separate to the source of halide gas, such that a surface layer forms on the substrate and includes at least one species chosen from the group comprising carbides, nitrides, carbonitrides, oxycarbonitrides and mixtures thereof. There is also provided an arrangement for introducing gases to a fluidised bed treatment facility.

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Citation (search report)

- No further relevant documents disclosed
- See references of WO 0047794A1

Designated contracting state (EPC)
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